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NOV 2 3 2001 😩	IN THE UNITED	STATES PATENT	AND TRADEMARK	OFFICE / SMC
	ation Serial No Date			09/234,233
Invent	or			. Weimin Li, et al
	nee			
	Art Unit			
	iner			
	ey's Docket No			MI22-1035
Title:	Semiconductor Proce	essing Method		

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted compliance with in 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art. Copies of the references are attached.

Match & Respectfully submitted,

Dated: 20 Nov 2001